

**Notice of References Cited**

Application/Control No.

09/975,297

Applicant(s)/Patent Under

Reexamination

OSSIPOV ET AL.

Examiner

Ida M Soward

Art Unit

2822

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,153,014	11-2000	Song	134/2
	C	US-			
	D	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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